



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
Takeshi YAMASHITA et al.)	Examiner: Kin-Chan Chen
Serial No. 10/759,180)	Art Unit: 1765
Filed: January 20, 2004)	Confirmation No. 7694
For: DRY ETCHING METHOD, FABRICATION METHOD)	
FOR SEMICONDUCTOR DEVICE, AND DRY)	
ETCHING APPARATUS)	

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

Applicants wish to note that the references noted on the attached form PTO-1449 were previously cited in the parent application Serial No. 09/826,098.

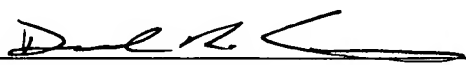
The Commissioner is hereby authorized to charge the fees, in the amount of \$180.00, in connection with this filing, which are required now, in compliance with the provisions of 37 C.F.R. §1.97(c), or credit any overpayment to Deposit Account No. 19-2380.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initial a copy of this form be returned to the undersigned.

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The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 19-2380.

Respectfully submitted,

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>			Complete if Known			
			Application Number		10/759,180	
			Filing Date		January 20, 2004	
			First Named Inventor		Takeshi YAMASHITA et al.	
			Art Unit		1765	
			Examiner Name		Kin-Chan Chen	
Sheet		of		Attorney Docket Number		740819-1041

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
		US-6,180,533 B1	01-30-2001	Jain et al.	
		US-6,402,974 B1	06-11-2002	Trevor et al.	
		US-5,872,063	02-16-1999	Chao et al.	
		US-6,060,371	05-09-2000	Shinmura	
		US-6,261,921 B1	07-17-2001	Yen et al.	
		US-6,124,212	09-26-2000	Fan et al.	
		US-			
		US-			
		US-			
		US-			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³	Number ⁴ Kind Code ² (if known)			
		JP	01-106432	04/24/1989	Nakamura Moritaka	AB
		JP	03-280536	12/11/1991	Nishino Hirotake et al.	AB
		JP	08-288256	11/01/1995	Tatsumi Tetsuya	AB
		JP	09-082495	03/26/1997	Tomioaka Kazuhiro et al.	AB
		JP	11-145111	05/28/1999	Jiwari Nobuhiro et al.	AB
		JP	11-238722	08/31/1999	Okamura Hideaki et al.	AB
		JP	11-251292	09/17/1999	Nagayama Tetsuji	AB

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.